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Faxed: May 10, 2004

Applicant: Berman, et al.

Invention: METHOD AND APPARATUS FOR DETECTING BACKSIDE  
CONTAMINATION DURING FABRICATION OF A SEMICONDUCTOR WAFER

Application No.: 10/628,601

Filed: July 28, 2003

Attorney Docket No.: 31692-73091

Transmitted Herewith for filing by facsimile: Amendment (5 pages)

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Customer No.:

Application No.: 10/628,601

Confirmation  
No.: 4653

Filing Date: July 28, 2003

Group Art Unit: 2812

Examiner Name: Olivia T. Luk

Attorney  
Docket No.: 31692-73091First Named  
Inventor: Berman et al.Title: METHOD AND APPARATUS FOR  
DETECTING BACKSIDE  
CONTAMINATION DURING  
FABRICATION OF A  
SEMICONDUCTOR WAFER

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AMENDMENTHonorable Commissioner for Patents  
P.O. Box 1450  
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Sir:

In response to the Office Action of February 24, 2004, please consider the  
following:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.